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(54) Title: METHOD FOR PREPARING GE<sub>1-x-y</sub>Sn<sub>x</sub>E<sub>y</sub> (E=P, As, Sb) SEMICONDUCTORS AND RELATED Si-Ge-Sn-E AND Si-Ge-E ANALOGS

(57) Abstract: A process for is provided for synthesizing a compound having the formula E(GeH<sub>3</sub>)<sub>3</sub> wherein E is selected from the group consisting of arsenic (As), antimony (Sb) and phosphorus (P). GeH<sub>3</sub>Br and [CH<sub>3</sub>)<sub>3</sub>Si]<sub>3</sub>E are combined under conditions whereby E(GeH<sub>3</sub>)<sub>3</sub> is obtained. The E(GeH<sub>3</sub>)<sub>3</sub> is purified by trap-to-trap fractionation. Yields from about 70% to about 76% can be obtained. The E(GeH<sub>3</sub>)<sub>3</sub> can be used as a gaseous precursor for doping a region of a semiconductor material comprising Ge, SnGe, SiGe and SiGeSn in a chemical vapor deposition reaction chamber.

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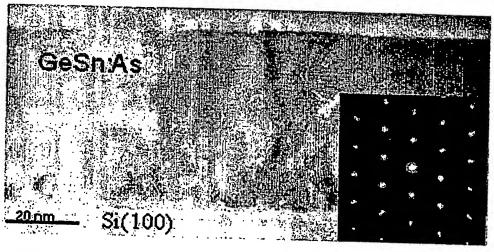
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[Continued on next page]

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